

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT**  
**(Under 37 CFR 1.97(b) or 1.97(c))**

Docket No.  
**OKI.390C**

In Re Application Of: **Kazuya Hizawa**

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/780,867	February 19, 2004	C. Novacek		2822	1983

Title: **A METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE HAVING A METALLIC SILICIDE LAYER**

Address to:  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**37 CFR 1.97(b)**

1. ☐ The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

**37 CFR 1.97(c)**

2. ☒ The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:
- ☐ the statement specified in 37 CFR 1.97(e);
- OR**
- ☒ the fee set forth in 37 CFR 1.17(p).

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**Payment of Fee**

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of \_\_\_\_\_ is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. 50-0238 as described below:
- ☒ Charge the amount of \$180.00
  - ☒ Credit any overpayment.
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Signature

Dated: June 2, 2005

ANDREW J. TELESZ, JR.  
REG. NO. 33,581

VOLENTINE FRANCO & WHITT, P.L.L.C.  
ONE FREEDOM SQUARE  
11951 FREEDOM DRIVE, SUITE 1260  
RESTON, VA 20190  
TEL. NO. (571) 283-0720

CC:

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# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

*(Use as many sheets as necessary)*

Sheet

1

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2

\_\_\_\_\_

Application Number

10/780,867
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Filing Date

February 19, 2004

First Named Inventor

Kazuya Hizawa

Art Unit

2822

Examiner Name

C. Novacek

Attorney Docket Number

OKI.390C

## U. S. PATENT DOCUMENTS

[illegible]

**FOREIGN PATENT DOCUMENTS**

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>2</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				
	A	JP 09-251967	09-22-1997	Fujitsu Ltd.		✓
	B	JP 2002-237470	08-23-2002	Sharp Corp.		✓
	C	JP 09-321304	12-12-1997	Seiko Epson Cor		✓
	D	JP 11-195620	07-21-1999	NEC Corp		✓
	E	JP 11-186194	07-09-1999	NEC Corp		✓
	F	JP 2001-250795	09-14-2001	Hitachi Ltd.		✓

Examiner  
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Date Considered

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 2

2

of

2

**Complete if Known**

Application Number	10/780.867
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Filing Date	February 19, 2004
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First Named Inventor	Kazuya Hizawa
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Art Unit	2822
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Examiner Name	C. Novacek
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Attorney Docket Number	OKI.390C
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## U. S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

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Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T <sup>2</sup>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				
	G	JP 2001-168308	06-22-2001	Canon Inc.		<input checked="" type="checkbox"/>
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						<input type="checkbox"/>
						<input type="checkbox"/>
						<input type="checkbox"/>
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**ATTY DOCKET #:** OKI.390C

**APPLICANT:** Kazuya Hizawa

**DUE DATE:**

**SERIAL NO.:** 10/780,867

**FILING DATE:** February 19, 2004

**TITLE:** A METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE  
HAVING A METALLIC SILICIDE LAYER

**RECEIPT OF THE FOLLOWING PAPERS IS ACKNOWLEDGED:**

Transmittal of Information Disclosure Statement; two (2) PTO/SB/08A Forms;  
English translation of Japanese Office Action; and Seven (7) references.

**DATE:** June 2, 2005

**ATTY:** AJT

**[Check No. n/a ]**

